

COPY

PATENT
20-3459P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicants: Shinichi NAGAHAMA et al.
Serial No.: 09/004,925 Group No.: Unknown
Filed: January 9, 1998 Examiner: Unknown
For: NITRIDE SEMICONDUCTOR DEVICE

LETTER

Assistant Commissioner for Patents
Washington, DC 20231

August 13, 1998

Sir:

Under the provisions of 35 U.S.C. § 119 and 37 C.F.R. § 1.55(a), the applicant(s) hereby claim(s) the right of priority based on the following application(s):

<u>Country</u>	<u>Application No.</u>	<u>Filed</u>
Japan	9-001937	January 9, 1997
Japan	9-012707	January 27, 1997
Japan	9-102793	April 3, 1997
Japan	9-134210	May 26, 1997
Japan	9-244342	September 9, 1997
Japan	9-274438	October 7, 1997
Japan	9-311272	October 27, 1997

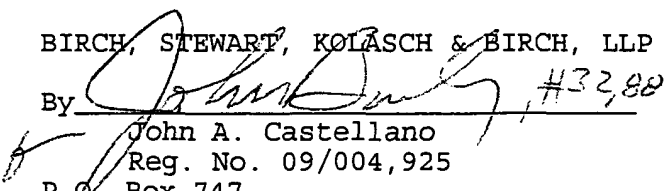
A certified copy of the above-noted application(s) is(are) attached hereto.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fee required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By

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Attachments
(Rev. 12/4/97)